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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: M. Kim

Examiner: Le, Thao P.

Serial No.: 10/659,954

Group: Art Unit 2818

Filed: September 11, 2003

Docket: 8836-185CIP (IB12070-US-1)

For: **Method of Forming Mos Transistor**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

AMENDMENT

This is a response to the Office Action mailed on September 22, 2004. Please amend the above-identified application as follows.

CERTIFICATE OF MAILING 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 10, 2004.

Dated: 12/10/04


Frank DeRosa